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121503

Docket No. 8034 USA L/W-C/W-C/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

19270 U.S.P.T.O.
10/736007

121503

Re: Inventor(s): Steven Verhaverbeke, Christopher Laurent Beaudry
Title: SINGLE WAFER CLEANING METHOD TO REDUCE PARTICLE DEFECTS ON A WAFER SURFACE

Transmitted herewith is the patent application identified above, including:

Specification, claims and abstract, totaling 30 pages.
 Drawings totaling 6 pages, Formal Informal.
 Executed Declaration and Power of Attorney.
 Assignment of the invention to Applied Materials, Inc.
 Assignment Recordation Cover Sheet
 Information Disclosure Statement and copy of cited reference.

FEE CALCULATION

Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	62	- 20 =	42	X \$18.00	756.00
Independent Claims	6	- 3 =	3	X \$86.00	258.00
Basic Filing Fee				\$770.00	\$770.00
Recording each patent assignment per property				\$40.00	\$40.00
TOTAL FEES					\$1824.00

The Commissioner is hereby authorized to charge \$1824.00 to Deposit Account No. 50-1074.
 The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
 Please address all future correspondence to:

**PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O.BOX 450A
Santa Clara, CA. 95052**

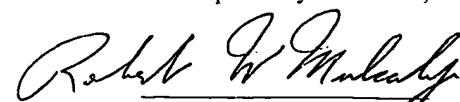
I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Express Mail Receipt No. EV 409362405 US

Date of Deposit 12-15-03

Signature Emmaly

Respectfully submitted,



Robert W. Mulcahy
Registration No. 25,436